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APPLICANTS

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** CONTINUING DATA ***** *Ac*

This application is a DIV of 10/330,180 12/30/2002 PAT 6,716,752 *Ac*
 which is a CON of 09/977,505 10/16/2001 PAT 6,627,545 *Ac*
 which is a CON of 09/430,037 10/29/1999 PAT 6,337,292 *Ac*

** FOREIGN APPLICATIONS *****

JAPAN 1998-309237 10/29/1998 *Ac*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials <i>[Initials]</i>		

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TITLE
 Method of forming silicon oxide layer and method of manufacturing thin film transistor thereby

<input type="checkbox"/> All Fees
